



#10
Jude
8/23/02
PATENT
81877.0012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo NAKASHIMA, et al.

Serial No.: 09/816,643

Filed: March 23, 2001

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Art Unit: 1762

Examiner: Timothy H. Meeks

**RESPONSE TO RESTRICTION
REQUIREMENT**

Commissioner for Patents
Washington, D.C. 20231

I hereby certify that this correspondence
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Kimberly Yee 08/08/02

Name Date

Signature *Kimberly Yee*

Dear Sir:

In response to the Restriction Requirement dated July 26, 2002, Applicants,
without traverse, elect for prosecution the claims of Group I, Claims 1-9. If there
are any fees in connection with the filing of this response, please charge the fees to
our Deposit Account No. 50-1314.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: August 8, 2002

By: *Brian D. Martin*

Brian D. Martin

Registration No. 47,771

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